

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s): T. HIROI, et al  
Serial No.: 10/062,666  
Filed: February 5, 2002  
For: PATTERN INSPECTION METHOD AND  
SYSTEM THEREFOR  
Group: 2881  
Examiner: J. Berman

**AMENDMENT**

Mail Stop: Amendment (Fee)  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

July 29, 2008

Sir:

The following amendments and remarks are respectfully submitted in connection with the RCE of above-identified application filed June 16, 2008, in light of the interview conducted July 24, 2008, in response to the office action dated February 14, 2008. The amendments submitted are as listed below and as set forth on the following pages:

Amendment of the Claims; and

Remarks are included following the amendments.